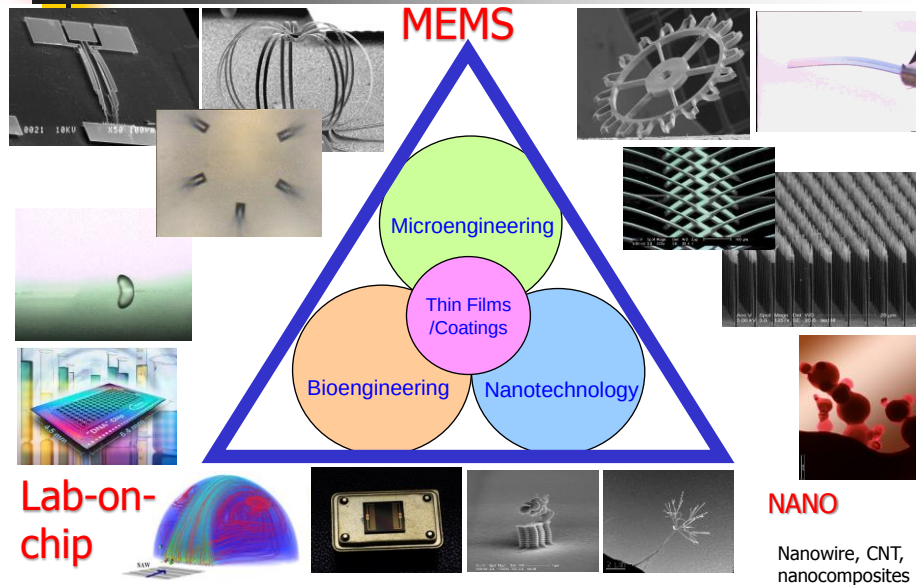


Dr. Richard Fu's work on Functional films for microactuator and lab-on-chip

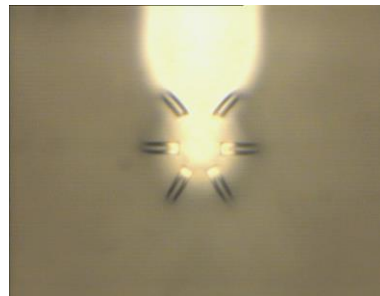


Functional/Smart Materials and Smart Microsystems

Which materials are **SMART**?

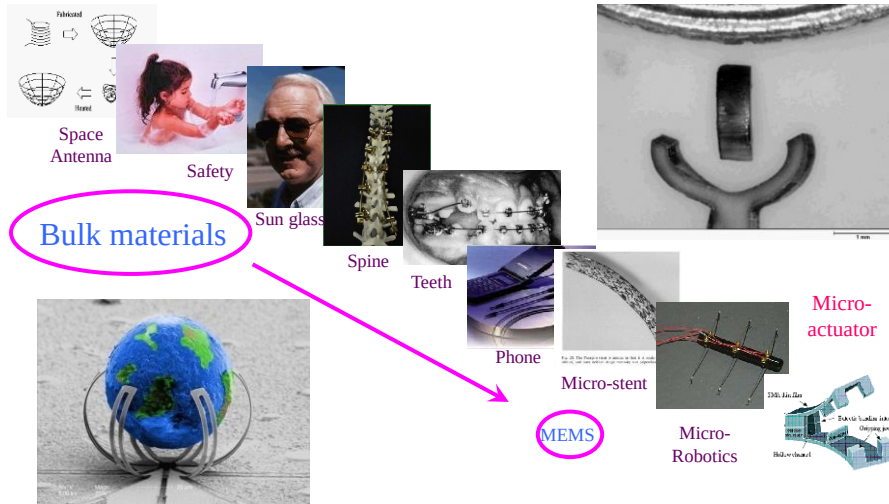
Materials or special design that change the properties in response to an external stimulation

- Piezoelectric Materials
- Shape Memory Alloys
- Smart polymers and nanocomposites
- Functional nanowires
- Diamond, DLC and carbon nanotubes—Smart functions



Shape memory thin films

Part I. Smart thin film Shape memory materials

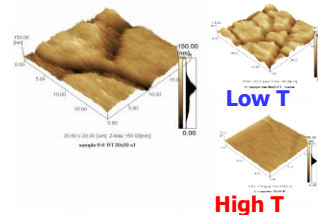
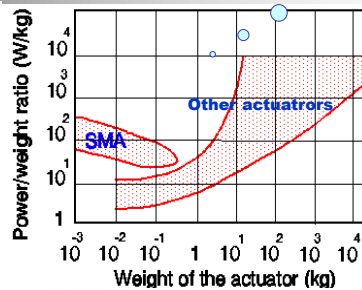


Y.Q. Fu, et al, Sens. Actuat., 112 (2004) 395-408

TiNi-good microactuator

That is why we use shape memory

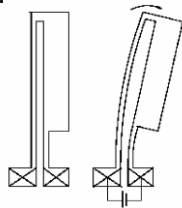
- **Actuation ability**
 - ✓ High power
 - ✓ Large displacement
- **Sensing ability**
 - ✓ Physical properties
 - ✓ Mechanical properties
 - ✓ Electrical properties
- **Other property**
 - ✓ Low-actuation temperature ($<80^{\circ}\text{C}$)
 - ✓ Good biocompatibility



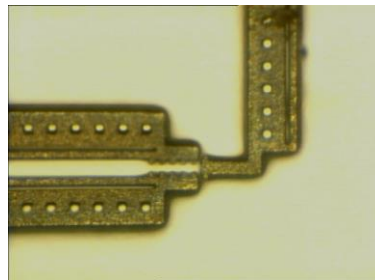
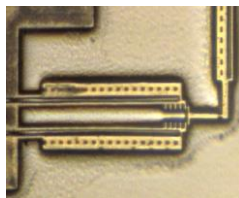
Y. Fu et al, Appl. Phys. Lett., 2006



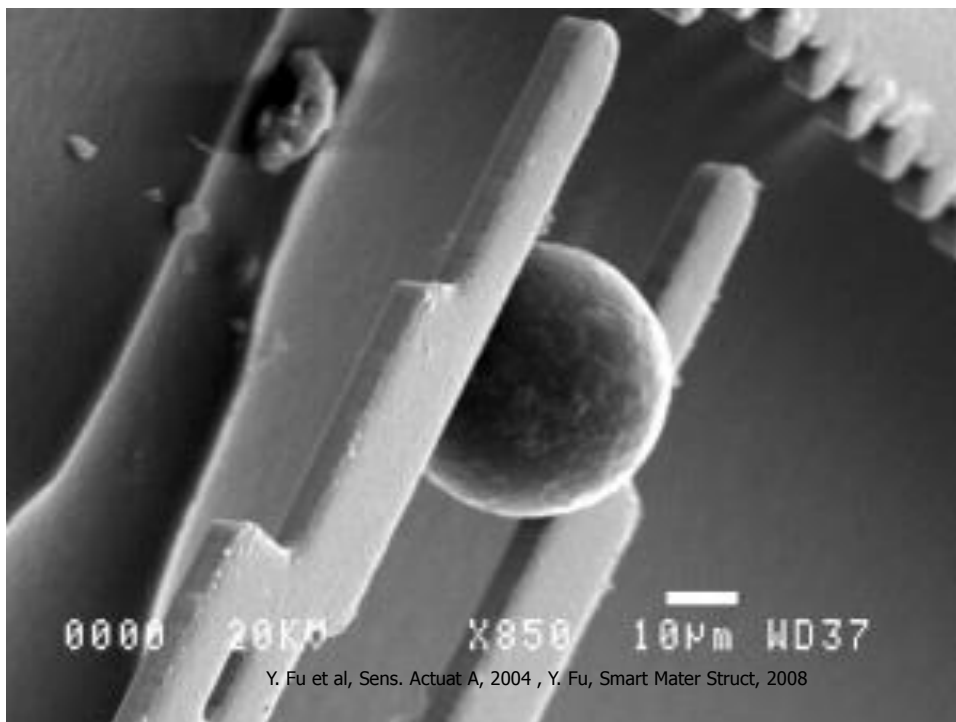
Lateral thermal gripper?



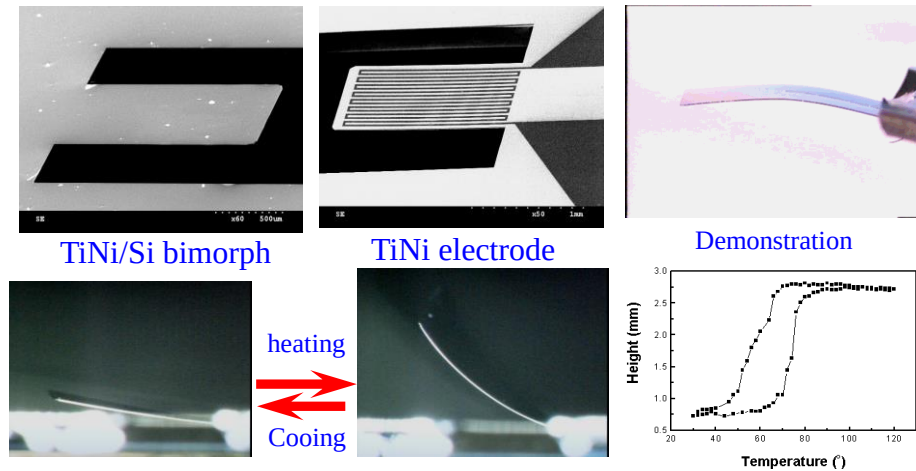
$$q = \text{Power} = I^2 R = \frac{I^2 L \rho}{A}$$



Electroplated Ni microlocker
From J. Luo, Y. Fu, Univ. Cambridge



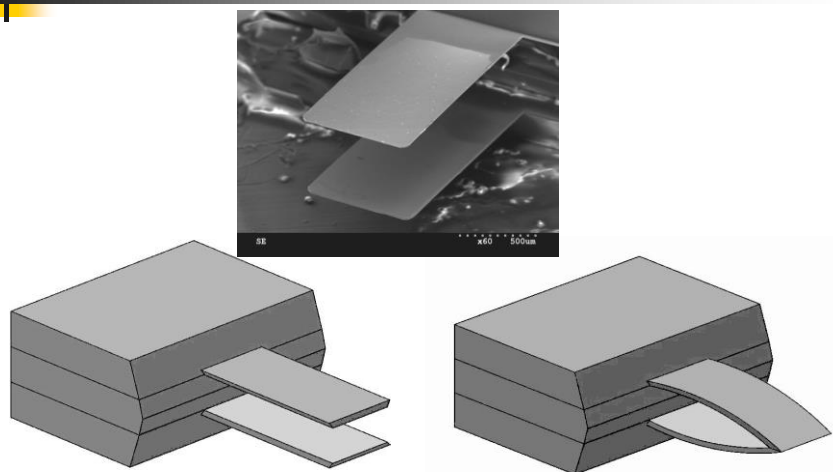
TiNi/Si out-of plane cantilever and gripper



Y. Fu, et al Surface Coat Technol. 2002

7 of 27

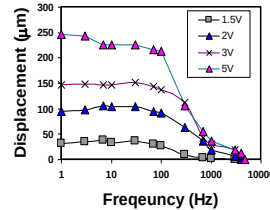
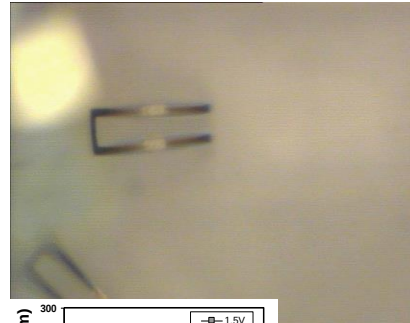
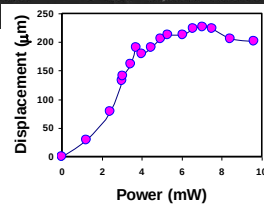
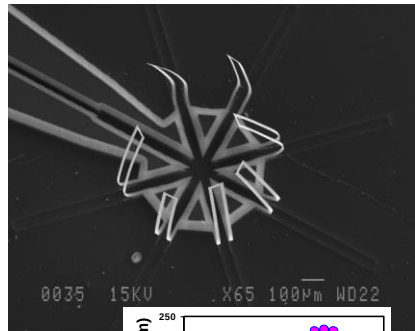
Microgripper by bonding



W.M. Huang, Y.Q.Fu et al J. MMM, 2003

8 of 27

Freestanding upwards TiNi microcage Microhand!!



Y. Fu et al, Smart Mater Struct, 2008

9

Reducing Opening Temperature

$$\frac{1}{R} = \frac{6 \cdot \varepsilon_{th}(1+m)^2}{d[3(1+m)^2 + (1+mn)(m^2 + (mn)^{-1})]} = \varepsilon_{th} \cdot S$$

Opening angle $\theta = 180L/\pi R$

Thermal strain $\varepsilon_{th} = \Delta\alpha\Delta T$

The opening of microcages

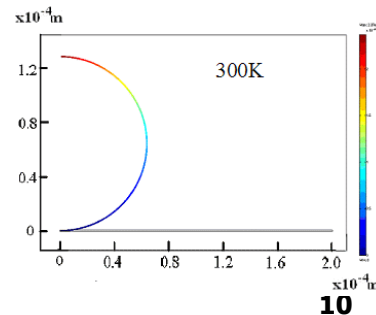
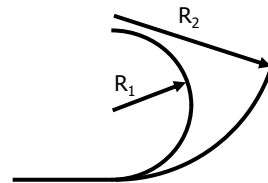
$$\Delta\theta = 180L/\pi (1/R_1 - 1/R_2) = 180L\Delta\alpha\Delta T S/\pi$$

To operate, $\Delta\theta = 90^\circ$ is sufficient

$$\Delta T = \pi / 2LS\Delta\alpha$$

independent of geometries

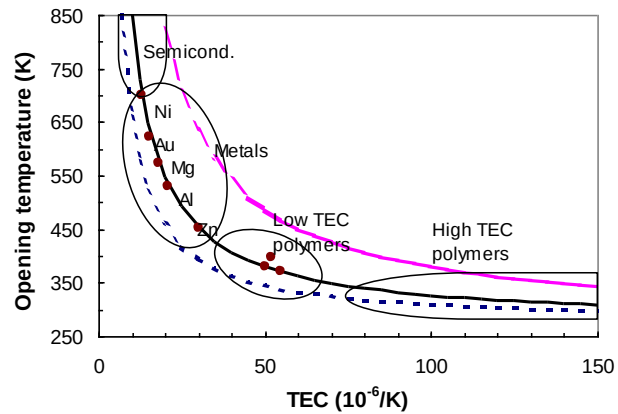
J Luo, Y. Fu, JMM 2005



10



Material Selection for Microcages



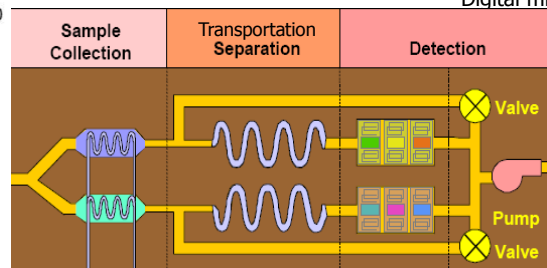
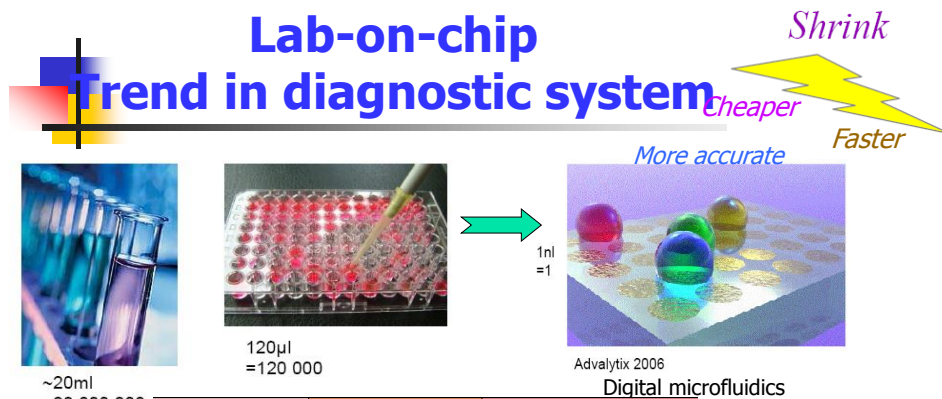
- Many materials can be used with DLC to make normally closed microcages
- Polymer based structure gives the lowest operating temperature

11



Part II. Smart lab-on-chip

Piezoelectric film based lab-on-chip: digital microfluidic and sensing

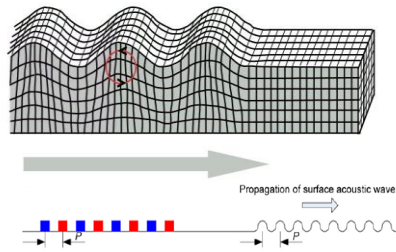


basic procedure for disease diagnosis

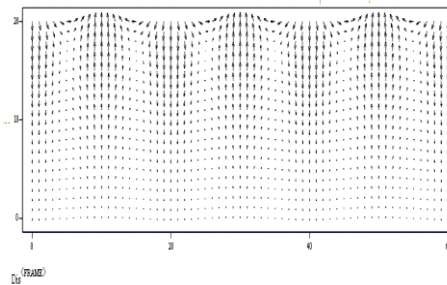
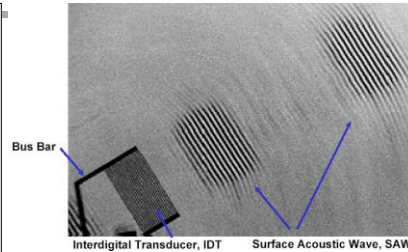
Surface acoustic wave (SAW)

- Piezoelectric film material
- Interdigital transducer
- RF signal
- Acoustic wave

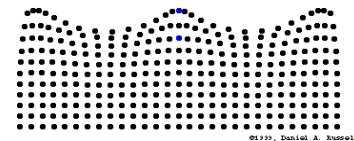
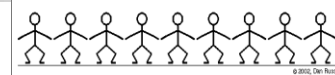
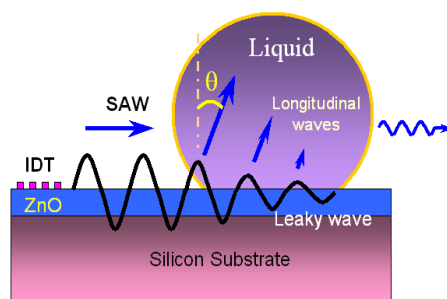
Rayleigh Wave



(Remark) P is a periodic length of surface acoustic wave, same as one periodic length of the inter-digital transducer (IDT)



Part I: Surface Acoustic wave microfluidics



•Rayleigh angle

$$\theta_R = \sin^{-1} \frac{C_w}{C_s}$$

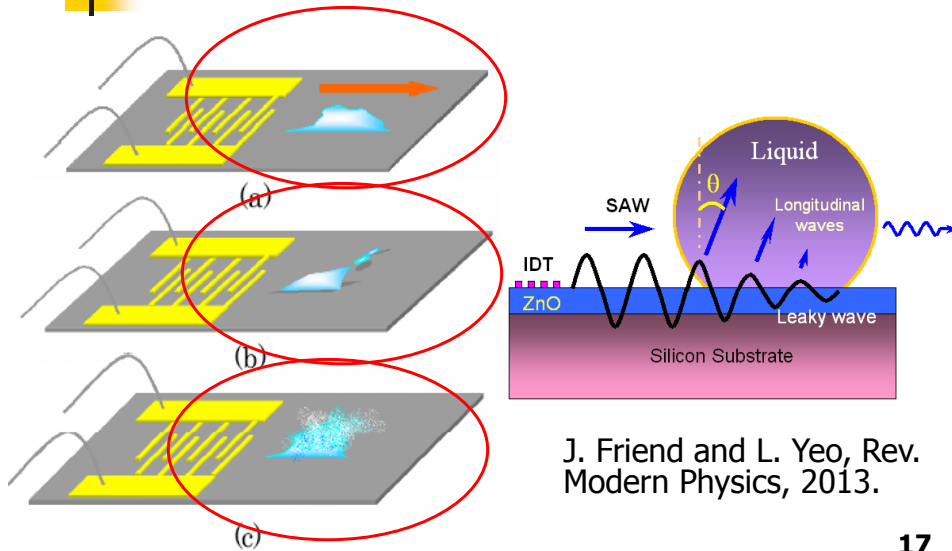
•Reynold's stress

$$\sigma_{ij} = \rho \overline{u_i u_j}$$

•SAW streaming force

$$F = \sum_{i=1}^3 \frac{\partial \overline{u_i u_j}}{\partial x_i}$$

Microfluidics-Pumping, jetting and nebulisation

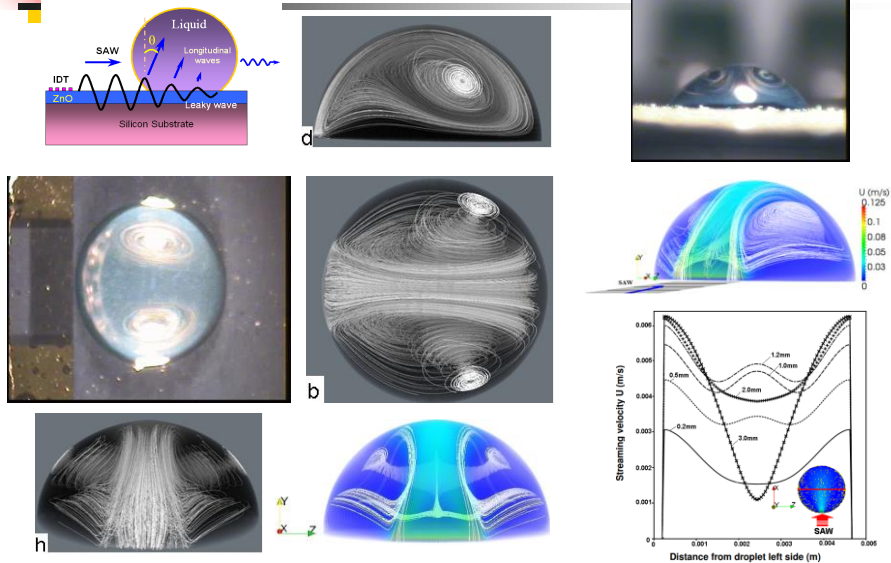


17

Common piezoelectric materials

Materials	Density (g/cm ³)	Piezo-constant d_{33} (pC/N)	Coupling coefficient, k	Effective coupling coeff. k^2 (%)	Acoustic speed (m/s)	Dielectric constant ϵ	TEC (x10 ⁻⁶)
ZnO	5.61	12	0.15-0.28, 0.33	1.5-1.7	2650	8.66	3.5-6
AlN	3.3	4.5, 6.4	0.17-0.5	3.1-8	11050	8.5-10	5.2
PZT	7.8	289-380	0.49	22, 5-35	4500	380	1.75
Quartz	2.64	2.3(d11)		8.8, 16	3700	4.3	5.5
LiNbO ₃	4.64	100	0.23, 0.21	2-11.3	3500	85 (29)	15
PVDF	1.79	-35	0.12-0.2	2.9	2600	6	75
PVDF/TrFE	1.88	-33.5	0.2-0.3	?	2200	6	56

Simulation of SAW Streaming effect- Finite volume analysis



M. Alghane, Y.Q.Fu, et al, J. Micromech. Microengng., 2010; J. Appl. Phys. 2011

Theory for SAW streaming and simulation

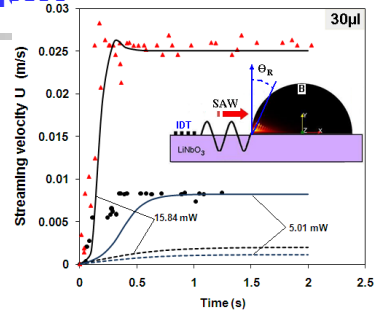
$$\frac{\partial \vec{U}}{\partial t} + (\vec{U} \cdot \nabla) \vec{U} = \vec{F} - \nabla p + \nu \nabla^2 \vec{U}$$

$$0 = \vec{F} - \nabla p + \nu \nabla^2 \vec{U}$$

$$F = -(1 + \alpha_1^2)^{\frac{3}{2}} A^2 \omega^2 k_i \exp 2(k_i x + \alpha_1 k_i z)$$

$$\frac{A}{\lambda} = 8.15 \times 10^{-6} P_D^{0.225} + 5 \times 10^{-6} P_D^{0.8}$$

$$\alpha^2 = 1 - \left(\frac{C_L}{C_W}\right)^2 \quad \alpha = j\alpha_1$$

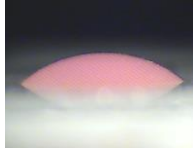


$$k_L = k_r + jk_i$$

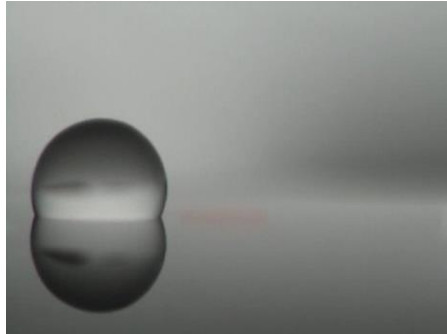
M. Alghane, Y.Q.Fu, et al,
Phys. Rev. E, 2012

Efficient pumping of liquid droplets

Hydrophilic

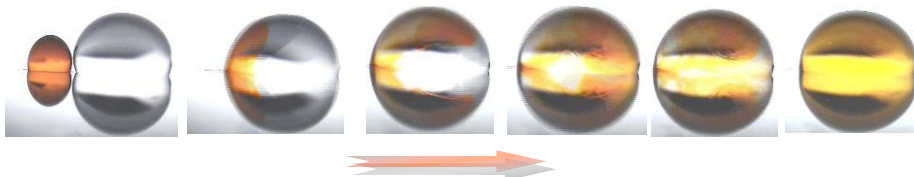
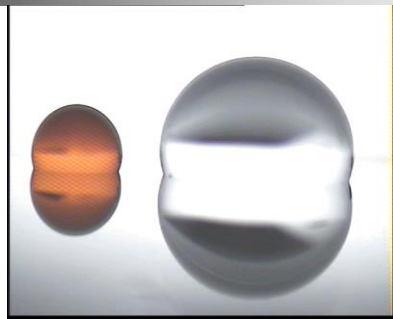


Hydrophobic



Droplet pumping

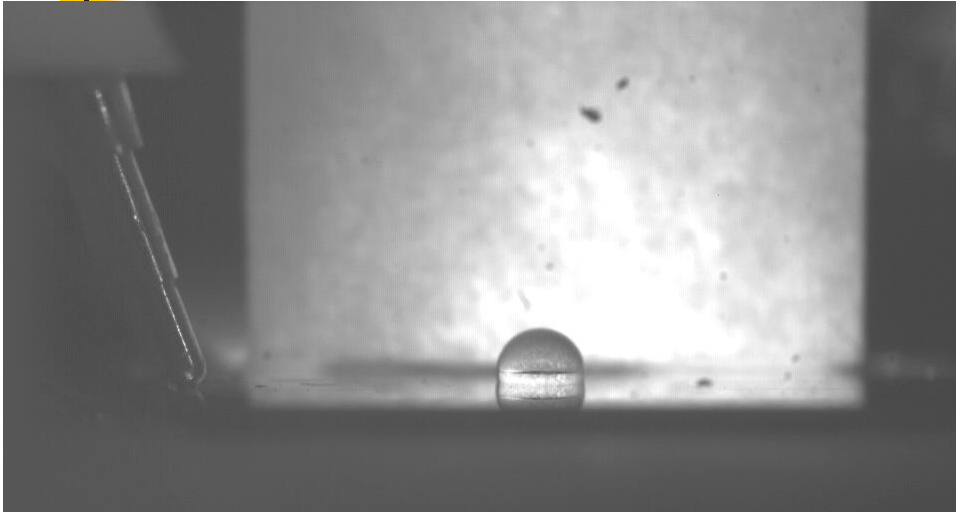
Microdroplet pumping and mixing



22



High speed ejection



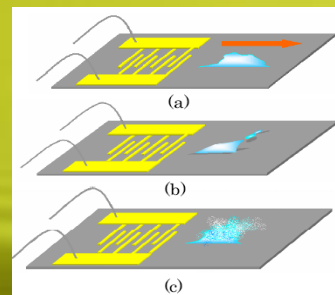
Collaboration with Prof. Jon Cooper, Glasgow University

23

Droplet vertical
ejection

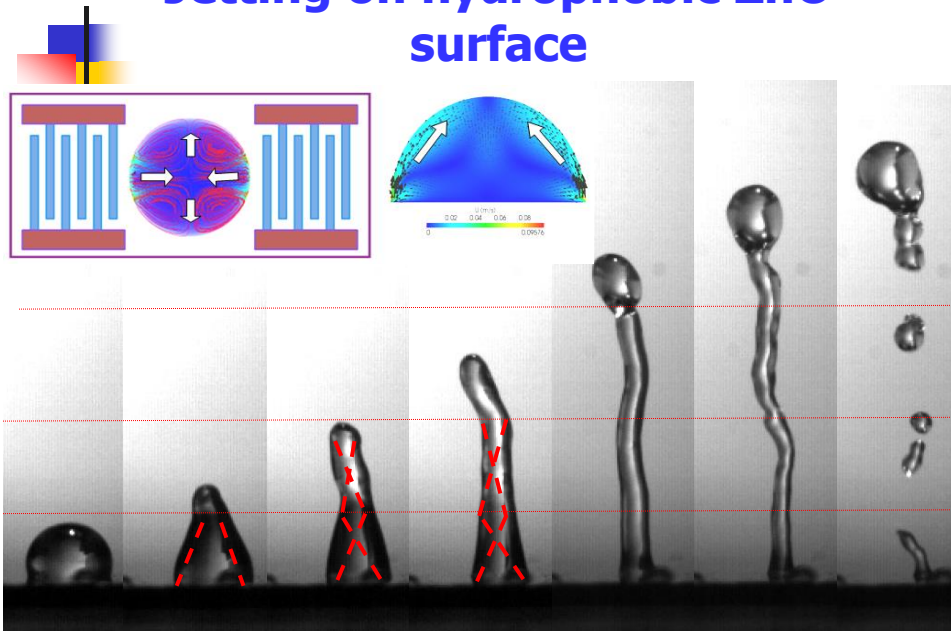
Circular
electrode?

Two opposite
electrodes?

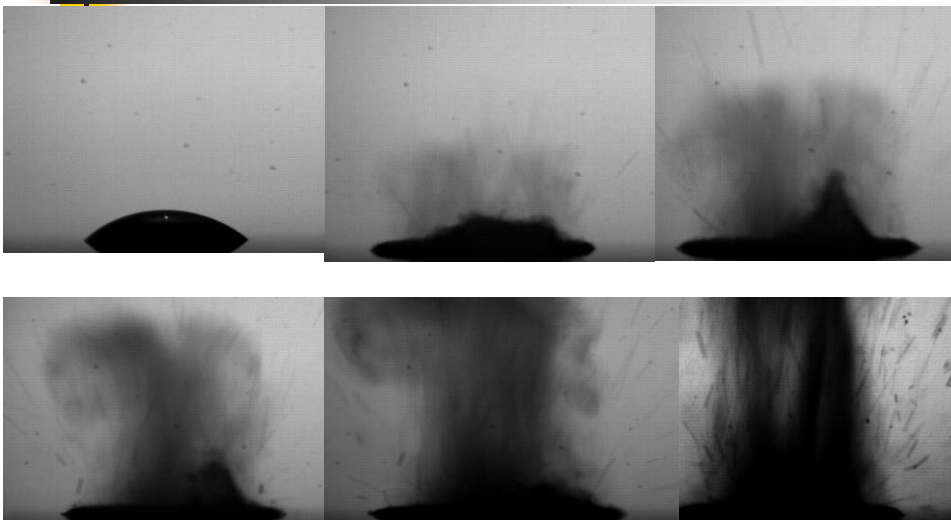


24

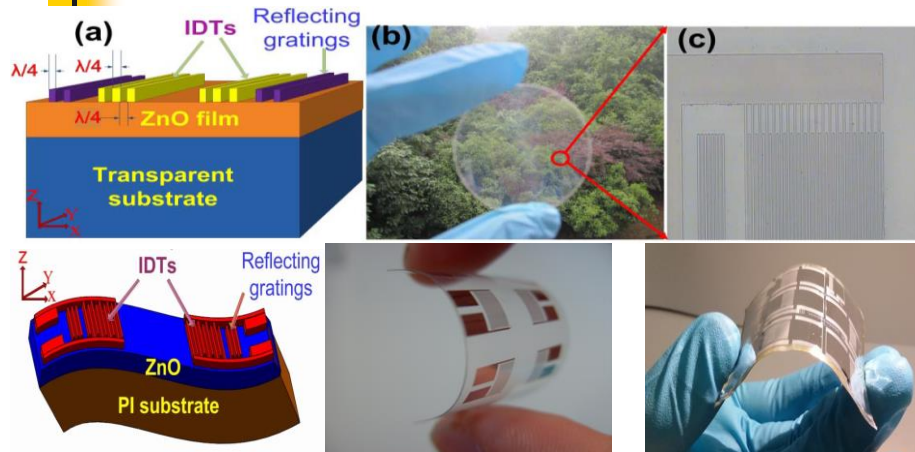
Jetting on hydrophobic ZnO surface



ZnO/Si film based nebulisation/atomization



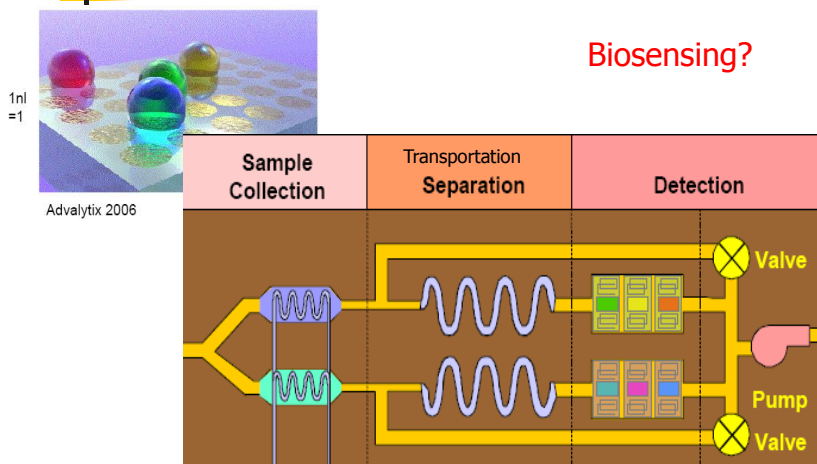
Transparent, flexible and deformable acoustic wave devices



Thin film SAW can be deposited on Si, glass, polymer, metal foils

Y Fu, et al Sens Actuat B, 2010 topic review paper

ZnO microfluidics, what about bio-sensing or biodetection?



basic procedure for disease diagnosis

28

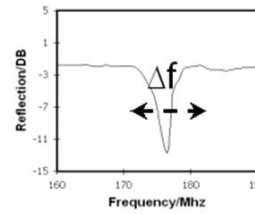
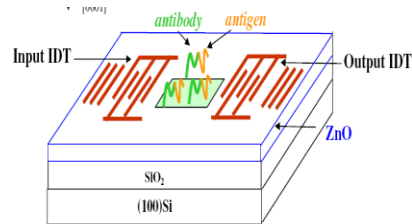
Biosensing using ZnO SAW devices

ZnO SAW is sensitive to

- Mass loading
- UV and chemical
- Viscosity change
- Gas sensing
- Electrical and capacitance

SAW signals

- Resonant frequency
- Amplitude
- Phase
- Impedance

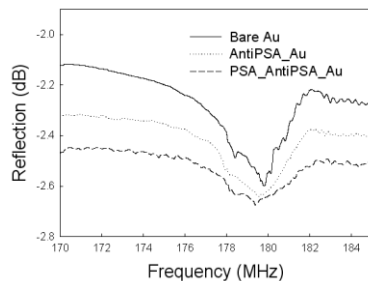
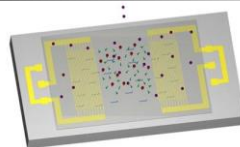


Frequency change

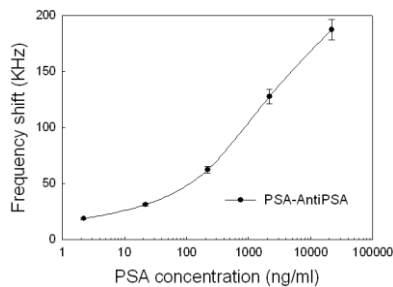
$$\Delta f = \frac{2\Delta m f_o^2}{A\sqrt{\rho\mu}}$$

Handheld and wireless

Biodetection results using ZnO thin Films



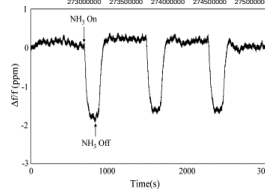
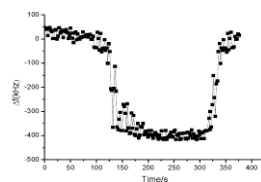
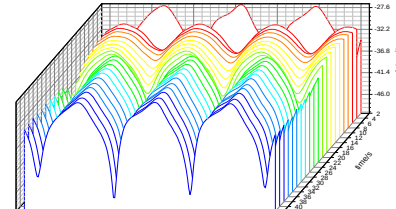
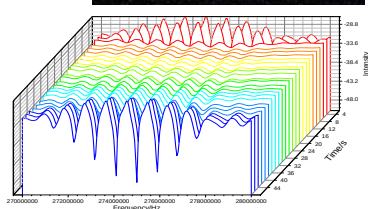
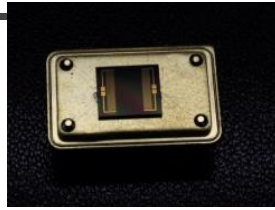
Reflection signals



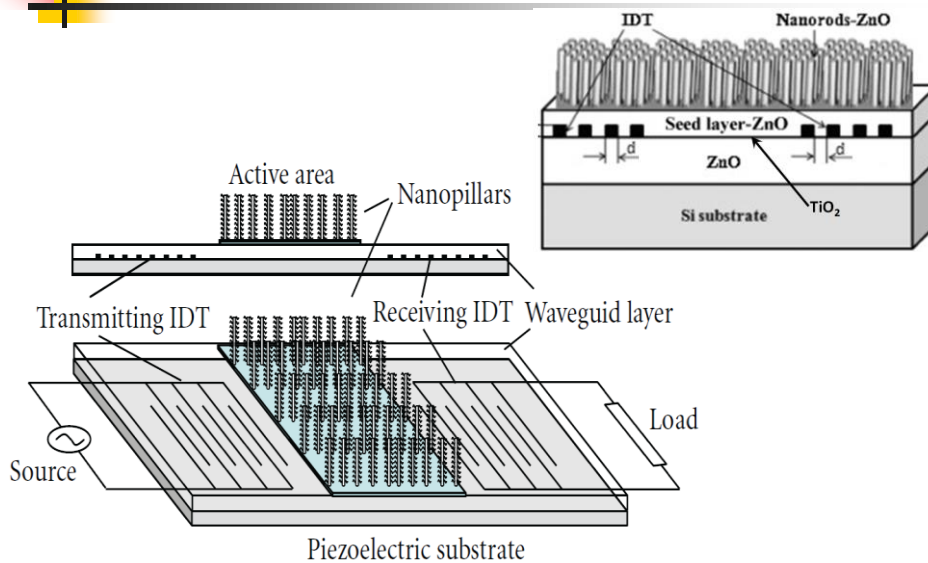
Detection of PSA concentration by Frequency changes

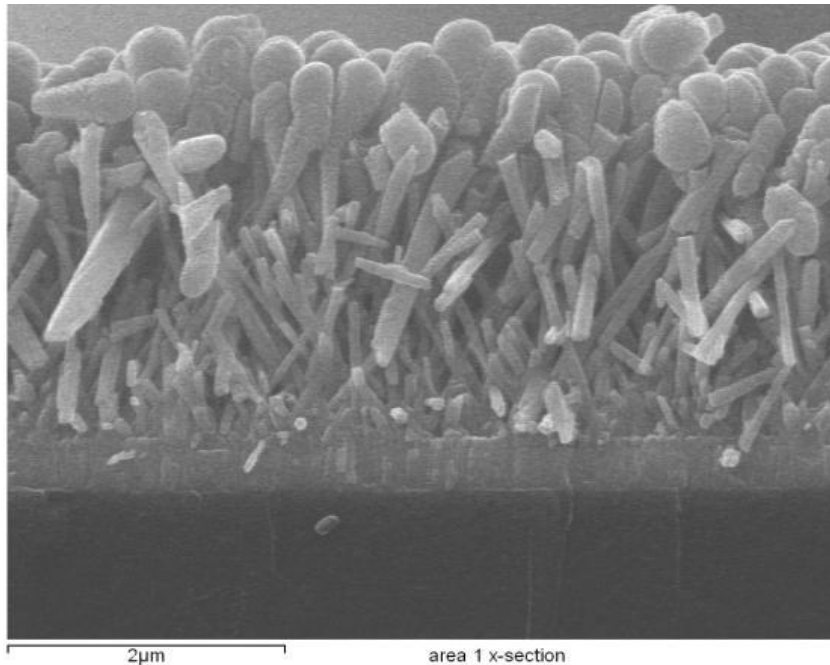
Kim, Luo ,Fu, J. Nanosci. Nanotechnol, 2009

NH₃ gas and VOC sensing results using nanowire based ZnO SAW



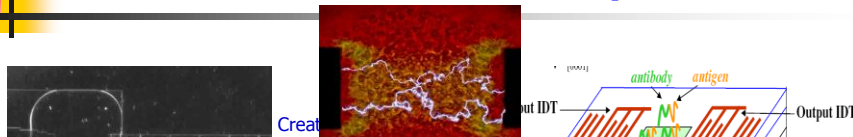
Enhanced sensing with nanowires





TiO₂ NW-ZnO nanowire and ZnO SAW device

Summary: ZnO/AlN film based Microfluidic lab-on-Chip



**Integration with photonics,
DEP, SPR, SERS, magnetic
particles, or others on ZnO SAW
platform**



Y.Q. Fu, et al, Sens. Actuat. B. 143 (2010) 606-619.

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- Prof. Bill Milne, Dr. A. Flewitt, University of Cambridge, **UK**
- Prof. J. Luo, Bolton University, **UK**
- Prof. Y. Pei and J. Th. M. De Hosson, University of Groningen, **Netherlands**
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- H.F. Pang, Prof. XT Zu, Y. Guo, **Univ. Electron Sci. Technol. China,**
- Prof. J. Cooper,, Y. Zhang, J. Rebond, R. Wilson, **University of Glasgow, UK**



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